

**In The Specification:**

Please amend the specification as follows:

Page 1, below are amendments made to the opening headers and paragraphs prior to the Background of the Invention.

**APPARATUS AND METHOD FOR NANOSCALE  
AND MICROSCALE MECHANICAL  
MACHINING AND PROCESSING**

**CROSS-REFERENCE TO RELATED APPLICATIONS**

This application claims priority to U.S. Provisional Patent Application No. 60/345,264 filed on January 3, 2002.

**~~APPARATUS AND METHOD FOR NANOSCALE  
AND MICROSCALE MECHANICAL  
MACHINING AND PROCESSING~~**

**STATEMENT REGARDING FEDERALLY SPONSORED  
RESEARCH OR DEVELOPMENT**

Some aspects of this invention were made in the course of Grant NSF 9977830 awarded by the National Institutes of Health and therefore the government has certain rights in some aspects of this invention.